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PATENT  
Attorney Docket No. 29925/39028

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	)	I hereby certify that this paper is being
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Jae-Chang Jung <i>et al.</i>	)	Service as first class mail, postage
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Serial No. 10/619,254	)	Mail Stop Amendment, Commissioner
	)	for Patents, P.O. Box 1450, Alexandria,
Filed: July 14, 2003	)	VA 22313-1450 on this date:
	)	
For: Organic Anti-Reflective Coating	)	December 12, 2005
Composition And Method For	)	
Forming Photoresist Patterns Using	)	
The Same	)	
	)	
Group Art Unit: 1752	)	<u><i>Andrew M. Lawrence</i></u>
	)	Andrew M. Lawrence, Reg. No. 46,130
Examiner: Richard L. Schilling	)	Attorney for Applicants

AMENDMENT "A"

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is in response to the official action dated August 12, 2005.

The **Amendments to the Claims** section (including a complete listing of claims) begins on page 2 of this paper.

The **Remarks** section begins on page 5 of this paper.